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# ***Optical System Alignment, Tolerancing, and Verification XIII***

**José Sasián**  
**Richard N. Youngworth**  
*Editors*

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# Contents

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## VERIFICATION AND ALIGNMENT

---

- 11488 04 **An approach to upgrading the beam transport system at the Navy Precision Optical Interferometer** [11488-2]
- 11488 05 **Verification of the optical system of the 9.7-m prototype Schwarzschild-Couder Telescope** [11488-3]
- 11488 06 **Linearization of defocus for projector optical alignment in structured light illumination systems** [11488-4]
- 11488 07 **Practical measurement of cell-phone camera lens focal length** [11488-5]

---

## TOLERANCING AND ALIGNMENT

---

- 11488 08 **Study of tolerancing optimization approaches in Zemax for as-built performance** [11488-6]
- 11488 09 **Sensitivity analysis of the CTE and thermo-optical coefficients of a passively athermalized lens** [11488-7]
- 11488 0A **Tolerance eigenmodes of optical systems (Invited Paper)** [11488-8]
- 11488 0B **Recent developments in tolerancing methods for imaging spectrometers** [11488-9]
- 11488 0C **Exact wavefront refracted through cemented doublet lenses** [11488-10]

---

## ALIGNMENT AND METHODS I

---

- 11488 0F **Adapting a prototype zoom lens to work outside its zoom range** [11488-13]
- 11488 0G **Using spherical aberration as a tool in aligning off-axis aspheric mirrors, as described in “Introduction to Optical Alignment Techniques”, a short course long offered through SPIE** [11488-14]

## **ALIGNMENT AND METHODS II**

---

- 11488 OI     **Alignment and verification testing of the GPS LRA test bed** [11488-16]
- 11488 OJ     **Aligning reflecting optics with Bessel beams** [11488-17]
- 11488 OK     **Hartmann testing and vibration for RST (WFIRST)** [11488-18]
- 11488 OL     **Data analysis algorithm for double-pass testing of the Roman Space Telescope** [11488-19]

## **POSTER SESSION**

---

- 11488 OO     **Development of a vacuum-compatible manipulator to calibrate wide field UV imagers for CubeSats** [11488-22]
- 11488 OP     **Optical characterization of electro-optics lenses for researching in optics** [11488-23]
- 11488 OQ     **Wavelength detection method using vortices** [11488-24]